Attorney's Docket No.: 12732-050002 / US4967D1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tatsuya Arao et al. Art Unit: Unknown Serial No.: New Divisional Application Examiner: Unknown

Filed : July 21, 2003

Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/873,334, filed on June 5, 2001. The attached list of references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 21, 2003

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U.S. Department of Commerce Patent and Trademark Office

Attorney's Docket No. 12732-050002

Application No. New Divisional

Application

Information Disclosure Statement

by Applicant

(Use several sheets if necessary)

Applicant Tatsuya Arao et al.

(37 CFR §1.98(b))

Filing Date July 21, 2003 Group Art Unit

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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Other Documents (include Author, Title, Date, and Place of Publication)					
Examiner Initial	Desig. ID	Document			
	AQ				
	AR				
	AS				
	AT				

Examiner Signature	Date Considered				
Examinor digitatore	Date Considered				
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with					
	the contract and not considered. Include copy of the form with				
next communication to applicant.					